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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/542,780	09/27/2005	Tetsuya Taki	PTGF-04041US	9224	
	7590 05/16/2008 GINN INTELLECTUAL PROPERTY LAW GROUP, PLLC			EXAMINER	
8321 OLD COURTHOUSE ROAD			GOODWIN, DAVID J		
SUITE 200 VIENNA, VA 22182-3817			ART UNIT	PAPER NUMBER	
			2818		
			MAIL DATE	DELIVERY MODE	
			05/16/2008	PAPER	

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

	Application No.	Applicant(s)
	10/542,780	TAKI, TETSUYA
Office Action Summary	Examiner	Art Unit
	DAVID GOODWIN	2818
The MAILING DATE of this communication ap Period for Reply	opears on the cover sheet with the o	correspondence address
A SHORTENED STATUTORY PERIOD FOR REPLY WHICHEVER IS LONGER, FROM THE MAILING IT  Extensions of time may be available under the provisions of 37 CFR 1 after SIX (6) MONTHS from the mailing date of this communication.  If NO period for reply is specified above, the maximum statutory period.  Failure to reply within the set or extended period for reply will, by statu Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	DATE OF THIS COMMUNICATION  .136(a). In no event, however, may a reply be tilt  d will apply and will expire SIX (6) MONTHS from the, cause the application to become ABANDONE	N. mely filed I the mailing date of this communication. ED (35 U.S.C. § 133).
Status		
Responsive to communication(s) filed on 13 in 2a) This action is <b>FINAL</b> . 2b) The 3) Since this application is in condition for allowed closed in accordance with the practice under	is action is non-final. ance except for formal matters, pro	
Disposition of Claims		
4)  Claim(s) 1-16 is/are pending in the applicatio 4a) Of the above claim(s) is/are withdra 5)  Claim(s) is/are allowed. 6)  Claim(s) 1-16 is/are rejected. 7)  Claim(s) is/are objected to. 8)  Claim(s) are subject to restriction and/	awn from consideration.	
9)☐ The specification is objected to by the Examir	ner.	
10) The drawing(s) filed on is/are: a) acceptable and applicant may not request that any objection to the Replacement drawing sheet(s) including the correct 11) The oath or declaration is objected to by the E	e drawing(s) be held in abeyance. Se ction is required if the drawing(s) is ob	e 37 CFR 1.85(a). ejected to. See 37 CFR 1.121(d).
Priority under 35 U.S.C. § 119		
12) Acknowledgment is made of a claim for foreig a) All b) Some * c) None of:  1. Certified copies of the priority documer 2. Certified copies of the priority documer 3. Copies of the certified copies of the pri application from the International Bures * See the attached detailed Office action for a list	nts have been received. nts have been received in Applicat ority documents have been receiv au (PCT Rule 17.2(a)).	ion No ed in this National Stage
Attachment(s)  1) Notice of References Cited (PTO-892)  2) Notice of Draftsperson's Patent Drawing Review (PTO-948)  3) Information Disclosure Statement(s) (PTO/SB/08)  Paper No(s)/Mail Date	4)  Interview Summary Paper No(s)/Mail D 5)  Notice of Informal F 6)  Other:	ate

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## **DETAILED ACTION**

## Claim Rejections - 35 USC § 103

- 1. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
  - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 2. Claims 1 through 3, 6 and 17are rejected under 35 U.S.C. 103(a) as being unpatentable over Yamamoto (US 6,064,079) in view of Yamamoto (US 6,064,079).
- 3. Yamamoto teaches a group III nitride based semiconductor device (column 1 lines 45-60). Said device comprises a first p-layer (16) and a second p layer (18) comprising an acceptor impurity (column 4 lines 30-60). An intermediate layer (32) provided between the first p layer (16) and the second p layer (18) the intermediate layer (32) contacting a surface of the first p layer (16) and a surface of the second p layer (18). The intermediate layer (32) contacts an entirety of the surface of the second p layer (18) and comprises a conductivity such that it prevents an applied voltage from concentrating on a part of a p electrode (22) side (fig 1a) (column 4 lines 35-65).
- 4. As the devices have the same structure there necessarily have the same function. MPEP 2112.
- 5. Yammamoto does not teach that the intermediate layer comprises a donor impurity.

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6. Yammaoto teaches a second embodiment comprising an intermediate layer (34) between a first p layer (15) and a second p layer (18). Said intermediate layer comprises a donor impurity (column 5 lines 25-55).

- 7. It would have been obvious to one of ordinary skill in the art to include donor dopant impurity into the intermediate layer in order to compensate for the p dopant and modulate the device.
- 8. The limitation must distinguish from the prior art in terms of structure rather than function, *In re Schreiber*, 128 F.3d 1473, 1477-78, 44 USPQ2d 1429, 1431-32 (Fed. Cir. 1997); See also *In re Swinehart*, 439 F.2d210, 212-13, 169 USPQ 226, 228-29 (CCPA 1971). Claims directed to apparatus must be distinguished from the prior art in terms of structure rather than function. *In re Danly*, 263 F. 2d 844, 847, 120 USPQ 528, 531 (CCPA 1959). "Apparatus claims cover what a device is, not what a device does." *Hewlett-Packard Co. v. Bausch & Lomb Inc.*, 909 F. 2d 1464, 1469, 15 USPQ2d 1525, 1528 (Fed. Cir. 1990).
- 9. Regarding claim 2.
- 10. Yamamoto teaches the donor impurity doped into the intermediate layer is doped with a concentration distribution corresponding to a concentration distribution of the acceptor impurity in the intermediate layer (fig 2B) (column 5 lines 35-60).
- 11. Regarding claim 3.
- 12. Yamamoto teaches the acceptor impurity is magnesium and the donor impurity is silicon (column 5 lines 10-45).
- 13. Regarding claim 6.

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14. Yamamoto teaches the first p layer (15) includes a p cladding layer (15) made of p type AlGaN doped with Mg (column 5 lines 10-25). The second p-layer (18) includes a p contact layer (18) made of p type GaN doped with Mg (column 5 lines 10-30).

- 15. Regarding claim 17.
- 16. Yamamoto teaches that that said low an intermediate layer (32) with a low cionductivity which will allow current flow in an entire region thereof (fig 1a) (column 4 lines 35-65).
- 17. Claims 4 and 5 are rejected under 35 U.S.C. 103(a) as being unpatentable over Yamamoto (US 6,064,079) in view of Yamamoto (US 6,064,079) as applied to claim 1 above and further in view of Fukuda (JP2003-115610).
- 18. Regarding claim 4.
- 19. Yamamoto in view of Yamamoto teaches elements of the claimed invention above in the rejection of claim 1.
- 20. Yamamoto does not teach the relative concentrations of the dopants.
- 21. Fukuda teaches a group III nitride semiconductor device. Said device comprises intermediate layers having concentration of Mg dopant of 1E18/cm<sup>3</sup> and intermediate layers having silicon dopant concentration of 1E17/cm<sup>3</sup> (translation paragraphs 0010-0015). The ration of which is 10 to 1.
- 22. It would have been obvious to one of ordinary skill in the art to dope the intermediate layer with these concentrations in order to reduce current leakage without affecting the crystal structure.
- 23. Regarding claim 5.

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24. The above concentrations of dopants will result in a hole density of less than 10^17/cm^3.

- 25. Claims 7 through 10 and 18 are rejected under 35 U.S.C. 103(a) as being unpatentable over Yamamoto (US 6,064,079) in view of Yamamoto (US 6,064,079) in view of Kaneyama (US 2002/0014632.
- 26. Regarding claim 7.
- 27. Yamamoto teaches that a group III nitride semiconductor device is formed on a sapphire substrate (10) (column 4 lines 25-45). An n contact layer (12) formed on the sapphire substrate (10) (column 4 lines 30-40). An n cladding layer (13) formed on the n contact layer (12) (column 4 lines 30-45). A light emitting layer (14) formed on the n cladding layer (13) (column 4 lines 30-50). A p cladding layer (15, 16) and a p type contact layer (18) to each of which an acceptor impurity is added (column 4 lines 35-55). An intermediate layer (32) provided between the p cladding layer (15, 16) and the p contact layer (18). A p electrode (22) is disposed on the p contact layer (18). An n electrode (21) disposed on the n contact layer (12).
- 28. Yammamoto does not teach that the intermediate layer comprises a donor impurity.
- 29. Yammaoto teaches a second embodiment comprising an intermediate layer (34) between a first p layer (15) and a second p layer (18). Said intermediate layer comprises a donor impurity (column 5 lines 25-55).

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30. It would have been obvious to one of ordinary skill in the art to include donor dopant impurity into the intermediate layer in order to compensate for the p dopant and modulate the device.

- 31. The limitation must distinguish from the prior art in terms of structure rather than function, *In re Schreiber*, 128 F.3d 1473, 1477-78, 44 USPQ2d 1429, 1431-32 (Fed. Cir. 1997); See also *In re Swinehart*, 439 F.2d210, 212-13, 169 USPQ 226, 228-29 (CCPA 1971). Claims directed to apparatus must be distinguished from the prior art in terms of structure rather than function. *In re Danly*, 263 F. 2d 844, 847, 120 USPQ 528, 531 (CCPA 1959). "Apparatus claims cover what a device is, not what a device does." *Hewlett-Packard Co. v. Bausch & Lomb Inc.*, 909 F. 2d 1464, 1469, 15 USPQ2d 1525, 1528 (Fed. Cir. 1990).
- 32. Yamamoto does not teach that the p electrode comprises a thin film electrode and a thick film electrode.
- 33. Kaneyama teaches group III nitride semiconductor device comprises a contact layer (109). A thin film electrode (110) is disposed on said contact layer (109). A thick film electrode (120) is disposed on the thin film electrode (109) (fig 1) (paragraph 0036-0039).
- 34. It would have been obvious to one of ordinary skill in the art to form an electrode of a thin film and a thick film in order to form a good electrical connection without blocking the emitted light.
- 35. Regarding claim 8.

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36. Yamamoto teaches that the light emitting includes a multi-quantum well structure (14) formed on the n cladding layer (13) by laminating multiple pairs of well layers of undoped InGaN and barrier layer of undoped GaN (column 4 lines 25-45).

- 37. Regarding claim 9.
- 38. Kaneyama teaches group III nitride semiconductor device comprises a contact layer (109). A thin film electrode (110) is disposed on said contact layer (109). Said thin film electrode (110) is formed of a layer of cobalt (111) and a second layer of gold (112) (paragraph 0038). A thick film p electrode (120) is disposed on the thin film electrode (109) (fig 1) (paragraph 0036-0039). Said thick film p electrode is formed by laminating a first layer of vanadium (121), a second layer of gold (122), and a third layer aluminum (123) sequence on the thin film p electrode (110) (paragraph 0039).
- 39. It would have been obvious to one of ordinary skill in the art to form an electrode of a thin film and a thick film in order to form a good electrical connection without blocking the emitted light.
- 40. Regarding claim 10.
- 41. Kaneyama teaches a reflective metal layer (150) of aluminum formed on the sapphire substrate (101) (paragraph 0040).
- 42. It would have been obvious to one of ordinary skill in the art to form a reflective metal layer in order to direct all emitted light in one direction thereby increasing the efficiency of the device.
- 43. Regarding claim 18.

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44. Yamamoto teaches that that said low an intermediate layer (32) with a low cionductivity which will allow current flow in an entire region thereof (fig 1a) (column 4

lines 35-65).

45.

- 46. Claims 11 through 15 and 19are rejected under 35 U.S.C. 103(a) as being unpatentable over Yamamoto (US 6,064,079) in view of Yamamoto (US 6,064,079) as applied to claim 1 above and further in view of Fukuda (JP2003-115610).
- 47. Regarding claim 11.
- 48. Yamamoto in view of Yamamoto teaches elements of the claimed invention above in the rejection of claim 1.
- 49. Yamamoto further teaches that the intermediate layer (32) has a high resistivity.
- 50. Yamamoto does not teach the relative concentrations of the dopants.
- 51. Fukuda teaches a group III nitride semiconductor device. Said device comprises intermediate layers having concentration of Mg dopant of 1E18/cm<sup>3</sup> and intermediate layers having silicon dopant concentration of 1E17/cm<sup>3</sup> (translation paragraphs 0010-0015). The ration of which is 10 to 1.
- 52. Further, an amount of donor impurity will inherently offset an amount of acceptor impurity.
- 53. It would have been obvious to one of ordinary skill in the art to dope the intermediate layer with these concentrations in order to reduce current leakage without affecting the crystal structure.

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The limitation must distinguish from the prior art in terms of structure rather than function, *In re Schreiber*, 128 F.3d 1473, 1477-78, 44 USPQ2d 1429, 1431-32 (Fed. Cir. 1997); See also *In re Swinehart*, 439 F.2d210, 212-13, 169 USPQ 226, 228-29 (CCPA 1971). Claims directed to apparatus must be distinguished from the prior art in terms of structure rather than function. *In re Danly*, 263 F. 2d 844, 847, 120 USPQ 528, 531 (CCPA 1959). "Apparatus claims cover what a device is, not what a device does." *Hewlett-Packard Co. v. Bausch & Lomb Inc.*, 909 F. 2d 1464, 1469, 15 USPQ2d 1525, 1528 (Fed. Cir. 1990).

- 55. Regarding claim 12.
- 56. Fukuda teaches that the intermediate layer (11) is about 100 nm (table 1).
- 57. It would have been obvious to one of ordinary skill in the art to form an intermediate layer of about 100 nm in order to sufficient charge blocking to prevent current flow.
- 58. Regarding claim 13.
- 59. Yamamoto does not teach the relative concentrations of the dopants.
- 60. Fukuda teaches a group III nitride semiconductor device. Said device comprises intermediate layers having concentration of Mg dopant of 1E18/cm<sup>3</sup> and intermediate layers having silicon dopant concentration of 1E17/cm<sup>3</sup> (translation paragraphs 0010-0015). The ration of which is 10 to 1.
- 61. It would have been obvious to one of ordinary skill in the art to dope the intermediate layer with these concentrations in order to reduce current leakage without affecting the crystal structure.

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62. Regarding claim 14.

63. Fukuda teaches a group III nitride semiconductor device. Said device comprises intermediate layers having concentration of Mg dopant of 1E18/cm<sup>3</sup> and intermediate layers having silicon dopant concentration of 1E17/cm<sup>3</sup> (translation paragraphs 0010-0015). This results in the donor and acceptor activation rates being substantially equal.

- 64. It would have been obvious to one of ordinary skill in the art to dope the intermediate layer with these concentrations in order to reduce current leakage without affecting the crystal structure.
- 65. Claims 15 is rejected under 35 U.S.C. 103(a) as being unpatentable over Yamamoto (US 6,064,079) in view of Yamamoto (US 6,064,079) as applied to claim 1 above and further in view of Nomura (US 2003/0147440).
- 66. Regarding claim 15.
- 67. Yamaoto teaches elements of the claimed invention above.
- 68. Yamaoto does not teach the composition of the AlGaN cladding layer.
- 69. Nomura teaches an AlGaN cladding layer comprised of Al.sub.0.15Ga.sub.0.85N (paragraph 0062).
- 70. It would have been obvious to one of ordinary skill in the art to use a cladding layer of Al.sub.0.15Ga.sub.0.85N in order to have the proper bandgap for generating light.
- 71. Regarding claim 19.

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72. Yamamoto teaches that that said low an intermediate layer (32) with a low cionductivity which will allow current flow in an entire region thereof (fig 1a) (column 4

lines 35-65).

73.

74. Claims 16 is rejected under 35 U.S.C. 103(a) as being unpatentable over Yamamoto (US 6,064,079) in view of Yamamoto (US 6,064,079) as applied to claim 1 above and further in view of Ishikawa (US 4,987,096).

75. Regarding claim 16.

- 76. Yamaoto in view of Yamamoto teaches elements of the claimed invention above.
- 77. Yamaoto in view of Yamamoto does not teach the concentration of dopant in the current blocking layer.
- 78. Ishikawa teaches a current blocking layer having a silicon dopant concentration of 2\*10^18 cm-3.
- 79. It would have been obvious to one of ordinary skill in the art to dope to a concentration of 2\*10^18 cm-3 in order to provide enough donors to block the acceptor charge carriers.

## Response to Arguments

80. Applicant's arguments with respect to claims 1 through 16 have been considered but are most in view of the new ground(s) of rejection.

## Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to DAVID GOODWIN whose telephone number is

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(571)272-8451. The examiner can normally be reached on Monday through Friday, 9:00am through 5:00pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Steven Loke can be reached on (571)272-1657. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

DJG

/Steven Loke/ Supervisory Patent Examiner, Art Unit 2818